Dear Applicant:

Thank you for your interest in Procedural Dermatology Fellowship Program (ACGME ID# 0813531004) at The Mount Sinai School of Medicine, Department of Dermatology. To apply you must be in or have successfully completed an ACGME accredited Dermatology residency. If you are a foreign medical graduate, all certifications, visas, and entry permits must be current and valid, for the duration of the training program, prior to final approval of any applicant. All licenses, ECFMG certification, INS visa and professional certifications are the applicant's responsibility. The Department does not operate its own J-1 or H-1 program. If selected, the fellow is required to obtain a license to practice medicine in the State of New York prior to starting their fellowship training.

Please note: This is an ACGME approved fellowship in procedural dermatology and is not associated with the MOHS College.

To apply, please submit the following documents:

1. A completed application form
2. A Curriculum Vitae
3. A personal statement
4. Three letters of recommendation (one of which must be from your residency program director)
5. A copy of your medical school graduation certificate/diploma
6. A copy of your ECFMG certificate (if applicable)
7. A list of completed or submitted abstracts or publications
8. Optional: a passport size photo. (Note: the photo is not used in the selection process)

Following a review of your application and letters of recommendation, you will be contacted if an invitation to interview is to be extended by the Fellowship Program Director.

If you have any questions or need further clarification, please contact the dermatology administration at (212) 659-9530. Please mail materials to: Procedural Dermatology Fellowship, Dermatology Administration Jose Gonzalez, One Gustave Levy Place, Box 1047, New York, NY 10029.

We look forward to receiving your application.

Jose Gonzalez
Department Administrator - Dermatology